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(54) Ultra fine groove chip and ultra fine groove tool

Ultra-feine Nutenschneidspitze und ultra-feines Nutenwerkzeug

Pointe d'usinage à rainures ultra-fines et outil à rainures ultra-fines

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EP-A- 0 358 526 EP-A- 0 597 723
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Description**BACKGROUND OF THE INVENTION****1. Field of the Invention**

[0001] The present invention relates to an ultra fine groove chip (or tip) according to the preamble of claim 1. It is intended the new chip less susceptibility of the working surface to thermal damage during the working in shear (ductile) mode and having high efficiency in disposing of swarf. The invention also relates to an ultra fine groove tool provided with the ultra fine groove chips according to the preamble of claim 10. A chip and a tool of the above type are known from EP-A1-0 597 723.

2. Description of the Related Art

[0002] With such difficult-to-cut brittle hard materials such as metal, crystals, glass or the like, it is vitally important to maintain the sharpness of tips by maintaining working resistance at a low level and by controlling heat, thereby maintaining the quality of work surface constant.

[0003] Brittle hard materials are particularly susceptible to surface cracking during working, which often is a cause of brittle fracture. The susceptibility to cracking of the brittle hard material is more pronounced when a larger-edged tool is used in any grinding, cutting or lapping process. Further, the fracture of a material occurs more often in a "brittle mode", which shall be considered to mean, throughout this specification, a state, wherein the surface of the brittle hard material is covered with cracks, as is often seen in a case when glass is rubbed with rough sandpaper, white powder is generated, and the glass turns opaque due to cracks produced on its surface.

[0004] Generally, when grinding a brittle hard material, swarf generated by brittle-mode grinding tends to be rough, and those by shear-mode tend to be fine and uniformly shaped. Here, the "shear mode" (or ductile mode) shall be understood to mean, throughout this specification, the following state. For example, the glass, as described above, if rubbed with a rough sandpaper, generates white powder and turns opaque due to cracks on its surface. On the other hand, if rubbed with a fine sandpaper under a very slight pressure, no white powder is generated and no cracking is caused. Such a crack-free state of the glass surface is called the shear mode where the initial transparency of the glass is mostly maintained after the glass is ground with very fine sandpaper under very slight pressure.

[0005] As an example of a tool employed for such working processes for workpieces as grinding, lapping, polishing or cutting, diamond grinding wheels are known for their excellent characteristics in performance, durability, precise finishing and so on.

1) Grinding

[0006] The following types (1)-(3) of the diamond grinding wheels are known:

- (1) An electroplated grinding wheel, wherein diamond abrasives are affixed by nickel-plating (type-1 diamond grinding wheel);
- (2) A grinding wheel, wherein diamond abrasives initially bonded onto a base surface by nickel-plating are subsequently reversed to obtain evenly leveled abrasive tops (type-2 diamond grinding wheel); and
- (3) A grinding wheel formed by sintering a mixture of fine diamond abrasives and a bonding material made of elastic resinoid or metal, which is particularly suitable for grinding brittle hard materials in the shear mode (type-3 diamond grinding wheel).

[0007] The above diamond grinding wheels of the related arts, however, have the following problems, respectively.

[0008] That is, the type-1 diamond grinding wheel has problems such as: (1) it has a limit in reducing surface roughness since sizes of diamond abrasives are irregular, and (2) it has a limit in reducing surface roughness since amount of abrasion and crushing state among the diamond abrasives are different each other due to irregularity of crystal orientations of the respective abrasive.

[0009] The type-2 diamond grinding wheel has problems such as: (1) a manufacturing process to evenly put the diamond abrasive tops in order by reversing is complicated, (2) amount of abrasion and crushing state among the diamond abrasives are different each other since crystal orientations of the respective abrasive are irregular, and (3) it is difficult to control the density of the diamond abrasive.

[0010] Lastly, the type-3 diamond grinding wheel has the following problems: (1) the volume of material removed per unit time is small and grinding efficiency is low because the diamond abrasives are very fine, (2) scratch is created on the workpiece surface due to loose abrasives, (3) the grinding force is reduced by loading and glazing of the grinding wheel during the grinding process, and the grinding burn occurs on the workpiece surface due to the grinding heat which is generated during the grinding process, and (4) it is liable to variations in grinding performance, truing and finishing efficiency due to a sintered product.

2) Cutting

[0011] Conventionally, a wide variety of materials and shapes have been adopted for cutting tools, and this is evident from manufacturing history. However, the necessity of using large-sized tips in cutting a hard-cutting material, whether it is metal or brittle hard material, is accompanied by heat generation. As a result, deterio-

ration in shape precision caused by unavoidable wear has not been preventable.

3) Lapping

[0012] Lapping differs from the grinding in that it is a constant-pressure processing, whereas the latter is a constant-feed processing. The manufacturing method of a lapping tool, therefore, has conventionally been identical with that for the grinding.

[0013] In accordance with the preamble of claim 1 and of claim 10, EP-A-0 597 723 discloses a polishing device having a carrier and plural polishing pads mounted on the carrier. Each polishing pad comprises an abrasive body, which is provided by a thermoplastic polymer impregnated with ultra-hard abrasive particles. Specifically, the abrasive layer comprises a regular array of recesses having the form of narrow capillary passages that extend for the full thickness of the abrasive layer. The passages have a circular cross section.

SUMMARY OF THE INVENTION

[0014] An object of the present invention, therefore, is to provide an ultra fine groove chip (or tip), wherein the coolant (or working fluid) retained in grooves serves to reduce thermal damage by stopping heat generation during the working. The advantage is particularly remarkable in a shear mode (or ductile mode) working of brittle hard materials.

[0015] This object is achieved by the features of claim 1. The present invention provides an ultra fine groove chip, wherein swarf removed from the workpiece is confined within grooves on the surface and are kept from interfering with the workpiece, thus realizing high working efficiency.

[0016] Still, the present invention provides an ultra fine groove chip, wherein the working resistance is small and constant, thus realizing high efficiency and high working precision.

[0017] The inventor has found that a tip made of hard material can serve this purpose, wherein the hard material may be selected from the group consisting of diamond, cubic boron nitride, tungsten carbide, cemented carbide, high-speed steel, and ceramics, and the tip has its face engraved with a number of fine grooves to form working surfaces, and whereby each working surface separated by grooves constitute an ultra fine edge. The present invention is based on the above finding. Further, the tool according to the present invention does not need the load to the workpiece for the grinding. Although the conventional grinding method is operated as the load-constrained grinding, the method according to the present invention is operated as the depth of cut-constrained grinding.

[0018] According to one aspect of the present invention, there is provided an ultra fine groove chip (or tip), wherein a chip made of hard material selected from the

group consisting of diamond, cubic boron nitride, tungsten carbide, cemented carbide, high-speed steel, and ceramics, has its face engraved with a number of fine grooves to form working surfaces, and whereby each of the working surfaces separated by said grooves constitutes an ultra fine edge.

[0019] According to another aspect of the present invention defined by Claim 10, there is provided an ultra fine groove tool which is provided with a rotatable base board and at least one ultra fine groove chip, wherein said board holds as a holder the ultra fine groove chip and a chip made of hard material selected from the group consisting of diamond, cubic boron nitride, tungsten carbide, cemented carbide, high-speed steel, and ceramics, has its face engraved with a plurality of fine grooves to form working surfaces, and whereby a working surface thus separated by grooves constitutes an ultra fine edge.

[0020] The nature, principle and utility of the invention will become more apparent from the following detailed description when read in conjunction with accompanying drawings.

BRIEF DESCRIPTION OF THE DRAWINGS

[0021] In the accompanying drawings:

FIG.1 is a schematic perspective view of a boat-shaped ultra fine groove chip (or tip);

FIG.2 is an enlarged schematic view of S_1 part on a facade of ultra fine edges shown in FIG.1;

FIG.3 is a sectional view taken along the line X-X of FIG.2;

FIG.4 is a schematic perspective view of an ultra fine groove chip as illustrated in FIG.1, wherein the bow bottom face has a flat plane with an edge line thereof being straight;

FIG.5 is an enlarged schematic view of S_2 part on a facade of ultra fine edges of the ultra fine groove chip illustrated in FIG.4;

FIGs.6A and 6B illustrate a comparative test using two mono-crystal diamond tips of exactly the same shape, but one having ultra fine groove chips and the other without them, wherein FIG.6A is a side view and FIG.6B is a plane view;

FIGs.7A and 7B illustrate a shape of the ultra fine groove chip, wherein FIG.7A is a side view and FIG.7B is a plan view;

FIGs.8A and 8B illustrate an ultra fine groove lapping tool, wherein FIG.8A is a rear plan view and FIG.8B is a front view;

FIG.9 is a schematic view illustrating a configuration of another ultra fine groove lapping tool;

FIG.10 is a sectional view illustrating still another ultra fine groove tool;

FIG.11 is a rear plan view of the ultra fine groove tool of FIG.10;

FIG.12 is a graph showing the change in working

resistance of a silicon wafer over accumulated cutting times;

FIG.13 is a graph showing the change in surface roughness of a silicon wafer over accumulated cutting times;

FIG.14 is a rear plan view of a further ultra fine groove tool; and

FIG.15 is a rear plan view of yet another ultra fine groove tool.

DESCRIPTION OF THE PREFERRED EMBODIMENTS

[0022] An ultra fine groove chip (or tip) according to the present invention has its working surface grooved, thereby an edge of the groove constituting a negative cutting edge. The grooves on the working surface form a plurality of cutting edges, thus increasing the number of edges per surface area and decreasing the work load of each edge.

[0023] Thermal damage during the working is minimized, as the working fluid guided by and retained in the grooves stops heat generation. Interference of swarf with the workpiece is minimized, as removed swarf is confined within grooves of the working surface.

[0024] A small and constant working resistance makes a shear mode process possible, thus realizing high precision of the worked surface. Preferably the groove on the working surface shall have a depth of $0.001\mu\text{m}$ or more so as the working force of an ultra fine edge can be maintained at the same level, irrespective of the resistance (grinding resistance, cutting resistance, lapping resistance). Also, it is important that the depth shall be at least $0.01\mu\text{m}$ so as to permit smooth flow of the coolant (grinding fluid, cutting fluid, polishing fluid) and smooth disposal of swarf.

[0025] The ultra fine area of each edge constituted on the working surface enables production of swarf small enough to satisfy conditions for obtaining a shear mode surface. Further, the size of the area accounts for the sustainability of a constant working force and the overheating by friction with the workpiece. If the area of an edge is $0.000001\mu\text{m}^2$ or less, the working force of the ultra fine edge drops sharply and proper working force is no longer sustainable. On the other hand, if the area is $100,000\mu\text{m}^2$ or more, a degradation of the ultra fine edge is induced in a short time and an over-working on the work surface (work layer) occurs, thus resulting in insufficient surface precision. The proper area of each edge, therefore, is in a range from 0.000001 to $100,000\mu\text{m}^2$.

[0026] Referring now to the drawings, the ultra fine groove chip according to the present invention and embodiments thereof will be described.

Embodiment 1:

[0027] First, description will be made of the first em-

bodiment illustrated in FIGs.1-3.

[0028] FIG.1 is a schematic perspective view of a boat-shaped ultra fine groove chip according to the present invention, FIG.2 is an enlarged schematic view of an S_1 part on a facade of the ultra fine groove chip shown in FIG.1, and FIG.3 is a sectional view taken along a line X-X of FIG.1.

[0029] In these drawings, an ultra fine groove chip 1 comprises a tip 10, wherein its face has a plurality of fine grooves 11 regularly engraved by applying a laser or electric energy or by a method of chemical vapor deposition or machining to form working surfaces 12, and whereby each working surface separated by grooves constitutes an ultra fine edge 13. By using the ultra fine edge 13, materials can be worked under a small resistance, and this small and constant resistance as well as the guaranteed shear mode working results in an excellent precision of the worked surface.

[0030] Thermal damage during the working is minimized, as the working fluid guided by and retained in the fine grooves 11 stops heat generation. Interference of swarf with the workpiece is maximally avoided, as removed swarf is confined within the fine grooves 11 of the working surfaces 12. Preferably, the fine grooves 11 on the working surface 12 shall have depth of $0.001\mu\text{m}$ or more so that the working force of the ultra fine edge 13 can be kept at the same level irrespective of the resistance (grinding resistance, cutting resistance, lapping resistance). It is also important that the depth "d" of the groove 11 be at least $0.01\mu\text{m}$ in order to secure smooth flows of the coolant (grinding fluid, cutting fluid, polishing fluid) and smooth disposals of swarf.

[0031] Areas $S_1, S_2, S_3, S_4, \dots$ of each ultra fine edge 13 constituted on the working surface 12 accounts for the sustainability of a constant working force and the overheating generated by the friction with the workpiece. If the area of an ultra fine edge 13 is $0.000001\mu\text{m}^2$ or less, its working force drops sharply and the proper level is no longer sustainable. On the other hand, if the area of the ultra fine edge 13 is $100,000\mu\text{m}^2$ or more, a degradation of the ultra fine edge 13 is induced in a short time, resulting in insufficient working precision. The proper area of each edge, therefore, is in the range from 0.000001 to $100,000\mu\text{m}^2$.

[0032] The ultra fine groove chip 1 illustrated in FIG. 1 has the working surfaces 12 consisting of side faces 12_1 and 12_2 , bottom face 12_3 , and bow bottom face 12_4 , each being shaped in flat or curved planes. The working surfaces 12 may also consist of curved planes only.

[0033] In FIG.3, the fine grooves 11 are formed to have a pitch "p" in the range of from $0.001\mu\text{m}$ to 1mm and a width "w" of $0.01\mu\text{m}$ or more.

[0034] As mentioned above, although a wide variety of materials and shapes have been adopted for cutting tools, the necessity of using large-sized tips in cutting a hard-cutting material, whether it is metal or brittle hard material, is accompanied by heat generation. As a result, deterioration in shape precision caused by una-

voidable wear has not been preventable. For solving the above problems, the ultra fine groove chip according to the present invention is extremely effective.

Embodiment 2:

[0035] A second embodiment is described with reference to FIG.4, FIG.5, FIGs.6(A) and 6(B), FIGs.7(A) and 7(B). FIG.4 is a schematic perspective view of an ultra fine groove chip as illustrated in FIG.1, wherein a bow bottom face 12₄ has a flat plane with an edge line thereof being straight. The ultra fine groove chip as illustrated in FIG.1 and FIG.4 may be used as an edge for face cutting, cylindrical cutting, and planing on a fly cutter, a turning machine and so on. The ultra fine groove chip may also be used as a grinding edge not only for cup wheels as illustrated in FIGs.10, 11, 14 and 15 (which shall be referred to later) but also for other wheels such as plane cup wheels.

[0036] FIG.5 is an enlarged schematic view of an S₂ part on a facade of an ultra fine edge of the ultra fine groove chip illustrated in FIG.4. Whereas the arrangement of the ultra fine groove chips illustrated in FIG.2 is regular, that of FIG.5 is irregular. Depending on materials and working conditions, the irregular arrangements sometimes bring about excellent effects in cooling and disposal of swarf.

[0037] Turning now to a comparative test (with reference to FIGs.6(A) and 6(B)) using two mono-crystal diamond tips of exactly the same shape, but one having ultra fine groove chips and the other without these, results of the test are presented below. The workpiece is BK7 glass and the feed speed is set at 25 mm/min.

[0038] Beginning with the one with ultra fine groove chips, the workpiece surface is in full brittle mode at a working speed of 1500 rpm. At 3000 rpm, the shear mode is somewhat notable.

[0039] As the revolution speed gradually increased from 4500 rpm through 6000 rpm, the shear mode area also increased to reach maximum at 7500 rpm. This is results in the amount of material removed per the ultra fine edge becoming minimized. The cooling effect secured by coolant being fed within grooves also contributes to sustained normal working conditions even at higher revolution speeds.

[0040] In the other test, under the same working conditions, using the same shaped tips but without ultra fine groove chips, the entire surface of the same material continued to show the brittle mode despite increases in revolution speed. The result of the above test also demonstrates the remarkable advantages of the ultra fine groove chip.

[0041] As stated above, the manufacturing method of a lapping tool is identical with that for grinding and therefore drawbacks and problems to be solved are also the same. Accordingly, by using an ultra fine groove tool provided with ultra fine groove chips, the following advantages are achieved: (1) an improved distribution of

abrasive density or an equivalent thereof is effectively obtained, (2) it is possible to uniformly put the crystal orientation of the ultra fine groove cutting chip in order to a friction-optimized direction, and (3) it is possible to uniformly put size and height of the ultra fine groove chips in order and this is equal to the uniformity of the size and protrusion of abrasives.

[0042] In accordance with the design as described above, a lapping tool can be manufactured by such methods as laser, electric energy, chemical vapor deposition and machining or the like. The tool brings about such advantages as an improved lapping efficiency, an improved surface roughness, and a reduction of work affected layer.

Embodiment 3:

[0043] FIG.8(A) is a rear plan view of an ultra fine groove lapping tool and FIG.8(B) is an elevational view of an ultra fine groove lapping tool. The ultra fine groove chips are arranged on a disk with ultra fine edges S₃ formed onto undersides of the pellets. An enlarged view of the ultra fine edges S₃ is the same as those illustrated in FIGs.2 and 5. While the shape of pellets illustrated in FIGs.8(A) and 8(B) are cylindrical, other columnar shapes such as quadrilaterals, ellipses and polygons may be employed with ultra fine edges formed onto the undersides thereof. The pellets may also be arranged to have bows of boat-shaped ultra fine groove chips as illustrated in FIGs.1 and 4 traveling in the direction of rotation.

[0044] FIG.9 is a schematic view illustrating the configuration of another ultra fine groove lapping tool. This embodiment shows an application wherein a couple of ultra fine groove lapping tools are simultaneously processing each surface of a workpiece. Specifications of the ultra fine edges and the ultra fine groove chips as described in grinding.

Embodiment 4:

[0045] FIG.10 is a sectional view illustrating yet another ultra fine groove tool, and FIG.11 is a rear plan view of the ultra fine groove tool of FIG.10. This embodiment shows an application of the ultra fine groove tool, wherein the ultra fine groove chips made of diamond are arranged along concentric circles. A result of a comparison test with a conventional diamond tool revealed differences between the two as presented below.

[0046] The test was made on a mono-crystal silicon wafer as the test-piece by the same method as described in FIGs.6(A) and 6(B). However, the feed speed was set at 100mm per minute. The tool was rotated at 2000 rpm and the cutting depth was set at 2 μm.

[0047] FIG.12 is a graph showing the change in working resistance of a silicon wafer over accumulated cutting times. Namely, the graph shows the change of working resistance during the processing. The conventional

tool showed a gradual increase in working resistance caused by the degradation of diamond abrasives due to heat generation and by loading of swarf. The ultra fine groove tool, however, showed a constant working resistance without any such problems.

[0048] FIG.12 is a graph showing the change in surface roughness of a silicon wafer over accumulated cutting times. Namely, the graph shows the roughness corresponding to the accumulated volume of materials removed. In the case of a conventional tool, non-uniform orientations of diamond abrasives caused the uneven abrasion, which further caused the non-level protrusion of abrasives. Accordingly, the roughness increased as the accumulated volume of materials removed increased. In the ultra fine groove tool, all the ultra fine edges have the same orientation and the same initial protrusion. Therefore, no change in roughness occurs. As such, the difference between the two is clear.

Embodiment 5:

[0049] FIGs.14 and 15 are rear plan views of further ultra fine groove tools. These drawings show applications of the ultra fine groove tools, wherein the ultra fine groove chips are arranged with each of the ultra fine edge formed in rectangular and triangular shape. While these are almost the same as those illustrated in FIGs. 10 and 11, there are differences in the shapes of the ultra fine groove chips and their plural concentric arrangements. Further, the ultra fine edges may be formed in a circular or elliptical shape.

[0050] The present invention is comprised as described above and has the following effects regarding material to be processed and working conditions:

[0051] An optimum density distribution of cutting edges can be designed, and an optimum size of cutting edge and a distribution mode thereof can be designed. An ultra fine groove chip or tool with all cutting edges thereof having uniform orientation can be designed by choosing a crystal orientation less susceptible to wear and initial protrusions of cutting edges can be leveled. As the heat generated when working can be stopped by the working fluid retained in the grooves, the degradation of cutting edges is suppressed. Further, grooves facilitate easy disposal of swarf, and the evenness of abrasion volume among the cutting edges owing to uniform crystal orientation brings about an excellent roughness value of the worked surface. The sustained cutting capacity of edges facilitates maintaining the depth of the work affected layer at a low level despite the increase in worked volume. Still further, the stabilized grinding permits maintaining working precision at a high level, and as the crystal orientation in the ultra fine edges can be made uniform at high density, a shear-mode processing is possible on those otherwise impossible materials.

Claims

1. An ultra fine groove chip (1) made of hard material selected from the group consisting of diamond, cubic boron nitride, tungsten carbide, cemented carbide, high-speed steel, and ceramics **characterized in that** said chip (1) has its face engraved with a number of fine grooves (11) to form a plurality of working surfaces (12) in shear mode, wherein said grooves communicate with each other and each of said working surfaces (12) sectioned by said grooves (11) constitutes an ultra fine edge (13).
2. An ultra fine groove chip as claimed in Claim 1, wherein said grooves (11) have a depth of at least 0.00 1μm.
3. An ultra fine groove chip as claimed in Claim 1 or 2, wherein said working surface has an area in a range of from 0.000001 to 100,000 μm².
4. An ultra fine groove chip as claimed in one of Claims 1-3, wherein a working surface of said chip is one of a flat plane, a curved plane, and a combination of flat and curved planes.
5. An ultra fine groove chip as claimed in one of Claims 1-4, wherein a working surface of post of said chip is formed in one of a quadrilateral, a triangular, a circular or an elliptical shape.
6. An ultra fine groove chip as claimed in one of Claims 1-5, wherein said chip is made of a single crystal diamond having on its face a number of fine grooves engraved by such means as laser processing, machining, electric energy application, or by chemical vapor deposition, to form a number of working surfaces, and whereby each working surface thus separated by said grooves constitutes an ultra fine edge.
7. An ultra fine groove chip as claimed in one of Claims 1-5, wherein said chip is made of one of cubic boron nitride, tungsten carbide, cemented carbide, high-speed steel or ceramics having on its face a number of fine grooves engraved by such means as laser processing, machining, electric energy application, or by chemical vapor deposition, to form a number of working surfaces, and whereby each working surface thus separated by said grooves constitutes an ultra fine edge.
8. An ultra fine groove chip as claimed in one of Claims 1-5, wherein said chip is made of diamond having on its face a number of fine grooves regularly engraved by such means as laser processing, machining, electric energy application, or by chemical vapor deposition, to form working surfaces, whereby

a plurality of working surfaces thus sectioned by said grooves and arranged in matrix form constitute a plurality of ultra fine edges.

9. An ultra fine groove chip as claimed in one of Claims 1-5, wherein said chip is made of one of cubic boron nitride, tungsten carbide, cemented carbide, high-speed steel or ceramics having on its face a number of fine grooves regularly engraved by such means as laser processing, machining, electric energy application, or by chemical vapor deposition, to form working surfaces, whereby a plurality of working surfaces thus sectioned by said grooves and arranged in matrix form constitute a plurality of ultra fine edges. 5
10. An ultra fine groove tool comprising a rotatable base board and at least one ultra fine groove chip, wherein the rotatable base board as a holder holds the ultra fine groove chip and the chip made of hard material selected from the group consisting of diamond, cubic boron nitride, tungsten carbide, cemented carbide, high-speed steel and ceramics **characterized in that** said chip (1) has its face engraved with a number of fine grooves to form a plurality of working surfaces (12) in shear mode, wherein said grooves communicate with each other and each of said working surface thus separated by said grooves constitute an ultra fine edge (13). 10 15 20 25 30
11. An ultra fine groove tool as claimed in Claim 10, wherein said base board is made of a circular shape, and said ultra fine groove chips made of a single crystal diamond having a uniform crystallographic orientation are arranged in a row and are circularly mounted on said board. 35
12. An ultra fine groove tool as claimed in Claim 10 or 9, wherein said diamond chip is mounted to said holding board by a method of sintering, deposition, or plating. 40
13. An ultra fine groove tool as claimed in one of Claims 10-12, wherein said base board has a rotation axis line and is mounted so as to rotate about the axis line, and said working surfaces are formed on said board in a plurality of curved strips separated from the rotation axis by a plurality of coaxial arcs having different radii. 45

Patentansprüche

1. Ultrafeine Nutenschneidspitze (1) aus einem harten Werkstoff, welcher ausgewählt ist aus der Gruppe, welche Diamant, kubisches Bornitrit, Wolframkarbit, Hartmetall, Schnellstahl und Kermikmaterial beinhaltet, **dadurch gekennzeichnet, dass** in die 55

Fläche der Schneidspitze (1) eine Anzahl feiner Nuten (11) eingraviert ist, um mehrere Arbeitsflächen (12) im Schermodus aufweist, wobei die Nuten miteinander in Verbindung stehen und jede der durch die Nuten (11) abgeteilten Arbeitsflächen (12) eine ultrafeine Kante (13) bildet.

2. Nutenschneidspitze nach Anspruch 1, bei der die Nuten (11) eine Tiefe von mindestens 0,001 µm aufweisen.
3. Nutenschneidspitze nach Anspruch 1 oder 2, bei der die Arbeitsfläche eine Flächengröße im Bereich von 0,000001 bis 100 000 µm² besitzt.
4. Nutenschneidspitze nach einem der Ansprüche 1-3, bei der eine Arbeitsfläche der Nutenschneidspitze eine flache Ebene, eine gekrümmte Ebene und/oder eine Kombination aus flachen und gekrümmten Ebenen ist.
5. Nutenschneidspitze nach einem der Ansprüche 1-4, bei der eine Arbeitsfläche einer Säule der Startspitze gebildet ist durch eine vierseitige, eine dreiseitige, eine kreisförmige oder eine elliptische Form.
6. Nutenschneidspitze nach einem der Ansprüche 1-5, bei der die Schneidspitze aus einem Einkristall-Diamanten hergestellt ist, auf dessen einer Seite sich eine Anzahl feiner Nuten befindet, die durch Laserbearbeitung, Zerspanung, Aufbringen elektrischer Energie oder durch chemisches Niederschlagen aus der Dampfphase eingraviert sind, um eine Anzahl von Arbeitsflächen zu bilden, wobei jede durch die Nuten so getrennte Arbeitsfläche eine ultrafeine Kante bildet.
7. Nutenschneidspitze nach einem der Ansprüche 1-5, bei der die Schneidspitze aus kubischem Bornitrit, Wolframkarbit, Hartmetall, Schnellstahl oder Kermikmaterial gebildet ist, welches Material auf seiner Fläche einer Anzahl feiner Nuten enthält, die durch Laserbearbeitung, Zerspanung, Aufbringen elektrischer Energie oder durch chemisches Abscheiden aus der Dampfphase gebildet sind, um eine Anzahl von Arbeitsflächen zu bilden, wobei jede so durch die Nuten separierte Arbeitsfläche eine ultrafeine Kante bildet.

8. Nutenschneidspitze nach einem der Ansprüche 1-5, bei der die Schneidspitze aus Diamant hergestellt ist, auf dessen Fläche eine Anzahl feiner Nuten vorhanden ist, die regelmäßig durch Laserbearbeitung, Zerspanung, Aufbringen elektrischer Energie oder durch chemisches Niederschlagen aus der Dampfphase gebildet sind, um Arbeitsflächen zu bilden, wobei mehrere derart durch die Nuten abgeteilten Arbeitsflächen in Form einer Matrix meh-

rere ultrafeine Kanten bilden.

9. Nutenschneidspitze nach einem der Ansprüche 1-5, bei der die Schneidspitze aus kubischem Bornitrit, Wolframkarbit, Hartmetall, Schnellstahl oder Kermikmaterial hergestellt ist, wobei ihre Fläche eine Anzahl feiner Nuten enthält, die regelmäßig durch Laserbearbeitung, Zerspanung, Aufbringen elektrischer Energie oder durch chemisches Abscheiden aus der Dampfphase gebildet sind, um Arbeitsflächen zu bilden, wobei mehrere so durch die Nuten abgeteilte Arbeitsflächen in Form einer Matrix mehrere ultrafeine Kanten bilden. 5
10. Ultrafeines Nutenwerkzeug, umfassend eine drehbare Basisplatte und mindestens eine ultrafeine Nutenschneidspitze, wobei die drehbare Basisplatte als Halterung die ultrafeine Nutenschneidspitze hält und die Schneidspitze aus hartem Werkstoff gefertigt ist, ausgewählt aus der Gruppe, welche aus Diamant, kubischem Bornitrit, Wolframkarbit, Hartmetall, Schnellstahl und Kermikmaterial besteht, **dadurch gekennzeichnet, dass** die Schneidspitze (1) in ihrer Fläche eine Anzahl eingravierter feiner Nuten zur Bildung mehrerer Arbeitsflächen (12) im Schermodus enthält, und jede der so durch die Nuten temperierten Arbeitsflächen eine ultrafeine Kante (13) bildet. 10 15
11. Werkzeug nach Anspruch 10, bei dem die Basisplatte kreisförmige Form hat und die ultrafeinen Nutenschneidspitzen aus Einkristall-Diamant mit einer gleichmäßigen kristallographischen Orientierung bestehen, angeordnet in einer Reihe und kreisförmig an der Platte gehalten. 20 30 35
12. Werkzeug nach Anspruch 10 oder 9, wobei die Diamant-Schneidspitze an der Halteplatte durch Sintern, Niederschlagen oder Plattieren angebracht ist. 40
13. Werkzeug nach einem der Ansprüche 10-12, bei der die Basisplatte eine Drehachsenlinie aufweist und so gehalten ist, dass sie sich um die Achsenlinie dreht, und die Arbeitsflächen an der Platte in mehreren gekrümmten Streifen ausgebildet sind, die von der Drehachse durch mehrere koaxiale Kreisbögen verschiedener Radien getrennt sind. 45 50

Revendications

1. Pointe d'usinage (1) à rainures ultrafines en un matériau dur choisi dans le groupe constitué de diamant, de nitrure de bore cubique, de carbure de tungstène, de carbure cémenté, d'acier à coupe rapide et de céramiques (11) **caractérisée en ce que** ladite pointe d'usinage (1) a sa face gravée d'un cer- 55

tain nombre de rainures fines pour former une pluralité de surfaces de travail (12) en mode découpé, dans laquelle lesdites rainures communiquent les unes avec les autres et chacune desdites surfaces de travail (12) séparées par lesdites rainures (11) constituent un bord ultrafin (13).

2. Pointe d'usinage à rainures ultrafines selon la revendication 1, dans laquelle lesdites rainures (11) ont une profondeur d'au moins 0,001 μm . 10
3. Pointe d'usinage à rainures ultrafines selon la revendication 1 ou 2, dans laquelle ladite surface de travail a une superficie dans une plage comprise entre 0,000001 à 100 000 μm^2 . 15
4. Pointe d'usinage à rainures ultrafines selon l'une quelconque des revendications 1 à 3, dans laquelle une surface de travail de ladite pointe est une parmi un plan plat, un plan incurvé, et une combinaison de plans plats et incurvés. 20
5. Pointe d'usinage à rainures ultrafines selon l'une quelconque des revendications 1 à 4, dans laquelle une surface de travail d'un montant de ladite pointe d'usinage est formée selon une forme quadrilatérale, triangulaire, circulaire ou elliptique. 25
6. Pointe d'usinage à rainures ultrafines selon l'une quelconque des revendications 1 à 5, dans laquelle ladite pointe d'usinage est en diamant monocristallin ayant sur sa face un certain nombre de fines rainures gravées à l'aide, par exemple, d'un traitement laser, d'un usinage, d'une application d'énergie électrique, ou par dépôt en phase vapeur, pour former un certain nombre de surfaces de travail, et chaque surface de travail ainsi séparée par lesdites rainures constituant un bord ultrafin. 30 35 40
7. Pointe d'usinage à rainures ultrafines selon l'une quelconque des revendications 1 à 5, dans laquelle ladite pointe d'usinage est en un matériau choisi parmi le groupe constitué de nitrure de bore cubique, de carbure de tungstène, de carbure cémenté, d'acier à coupe rapide ou de céramiques ayant sur sa face un certain nombre de fines rainures gravées à l'aide, par exemple, d'un traitement laser, un usinage, une application d'énergie électrique, ou par dépôt en phase vapeur, afin de former un certain nombre de surfaces de travail, et chaque surface de travail ainsi séparée par lesdites rainures constituent un bord ultrafin. 45 50
8. Pointe d'usinage à rainures ultrafines selon l'une quelconque des revendications 1 à 5, dans laquelle ladite pointe d'usinage est en diamant ayant sur sa face un certain nombre de fines rainures gravées de façon régulière à l'aide, par exemple, d'un trai-

tement au laser, un usinage, une application d'énergie électrique, ou par dépôt en phase vapeur, pour former des surfaces de travail, une pluralité de surfaces de travail ainsi séparées par lesdites rainures et agencées en forme de matrice constituant une pluralité de bords ultrafins. 5

9. Pointe d'usinage à rainures ultrafines selon l'une quelconque des revendications 1 à 5, dans laquelle ladite pointe d'usinage est en un matériau choisi dans le groupe constitué de nitrure de bore cubique, de carbure de tungstène, de carbure cémenté, d'acier à coupe rapide ou de céramiques ayant sur sa face un certain nombre de fines rainures gravées de façon régulière à l'aide, par exemple, d'un traitement laser, un usinage, une application d'énergie électrique, ou par dépôt en phase vapeur, pour former des surfaces de travail, une pluralité de surfaces de travail ainsi séparée par lesdites rainures et agencées en forme de matrice constituant une pluralité de bords ultrafins. 10 15 20
10. Outil à rainures ultrafines comprenant une plaquette de base rotative et au moins une pointe d'usinage à rainures ultrafines, dans lequel la plaquette de base rotative, en tant que support, supporte la pointe d'usinage à rainures ultrafines et la pointe en un matériau dur choisi dans le groupe constitué de diamant, de nitrure de bore cubique, de carbure de tungstène, de carbure cémenté, d'acier à coupe rapide, et de céramiques, **caractérisé en ce que** ladite pointe d'usinage (1) a sa place gravée d'un certain nombre de fines rainures pour former une pluralité de surfaces de travail (12) en mode découpé, dans lequel lesdites rainures communiquent les unes avec les autres et chacune desdites surfaces de travail ainsi séparées par lesdites rainures constituent un bord ultrafin (13). 25 30 35
11. Outil à rainures ultrafines selon la revendication 10, dans lequel ladite plaquette de base est de forme circulaire, et lesdites pointes d'usinage à rainures ultrafines en un diamant monocristallin ayant une orientation cristallographique uniforme sont agencées sur une ligne et sont montées de façon circulaire sur ladite plaquette. 40 45
12. Outil à rainures ultrafines selon la revendication 10 ou 9, dans lequel ladite pointe d'usinage en diamant est montée sur ladite plaquette de support par un procédé de frittage, de dépôt ou de placage. 50
13. Outil à rainures ultrafines selon l'une quelconque des revendications 10 à 12, dans lequel ladite plaquette de base a une ligne d'axe de rotation et est montée de façon à effectuer une rotation autour de la ligne d'axe, et lesdites surfaces de travail sont formées sur ladite plaquette dans une pluralité de 55

bandes incurvées séparées de l'axe de rotation par une pluralité d'arcs coaxiaux ayant différents rayons.

FIG. 1

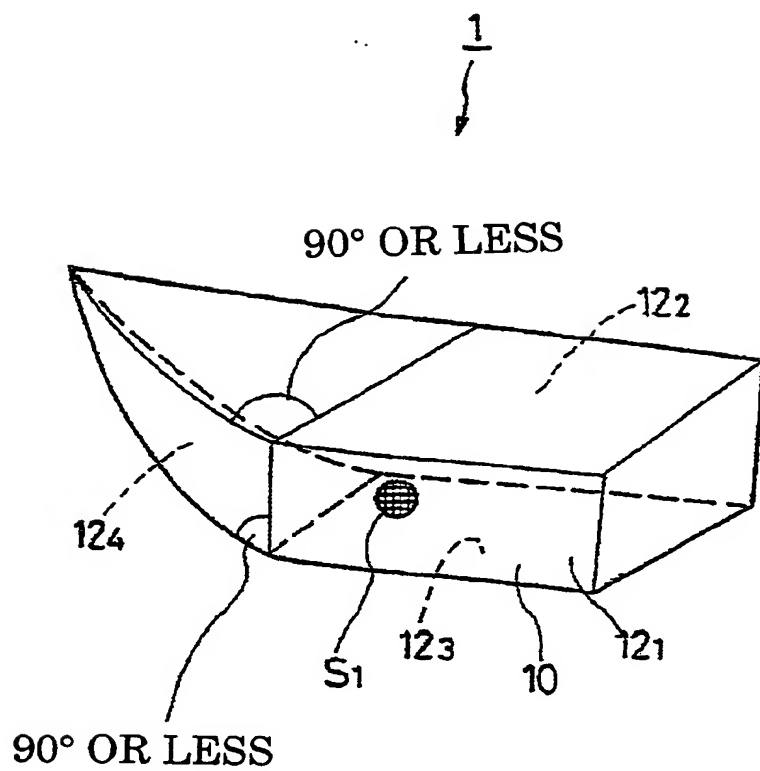


FIG. 2

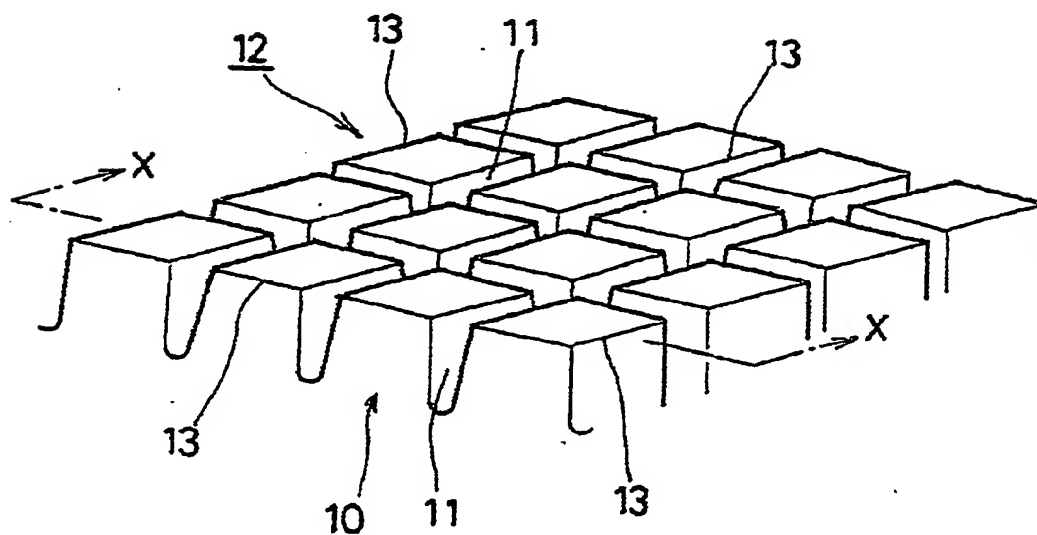


FIG. 3

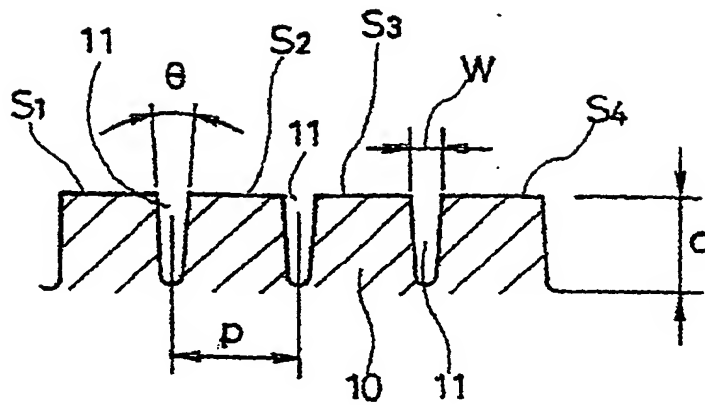


FIG. 4

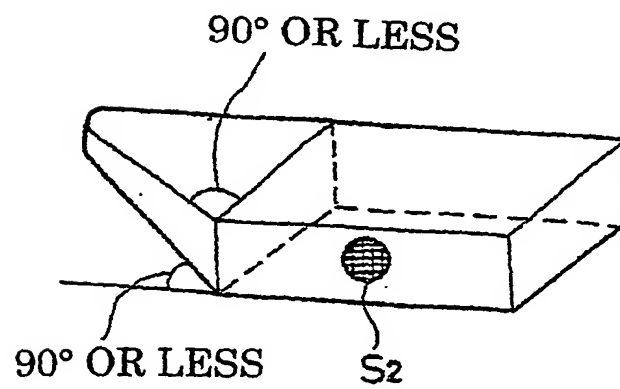


FIG. 5

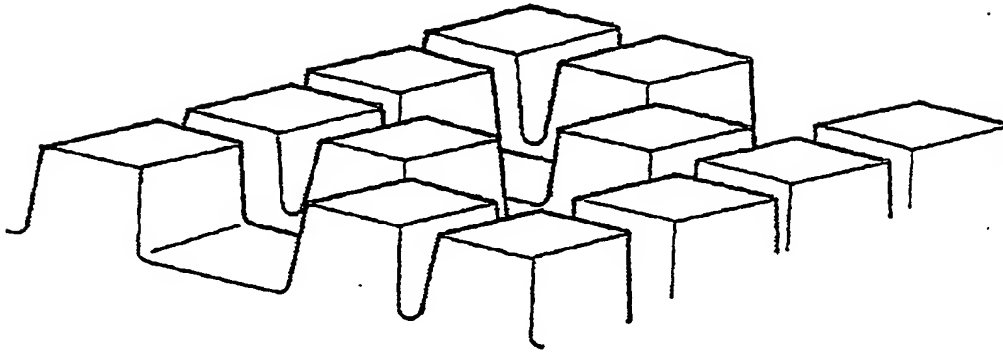


FIG. 9

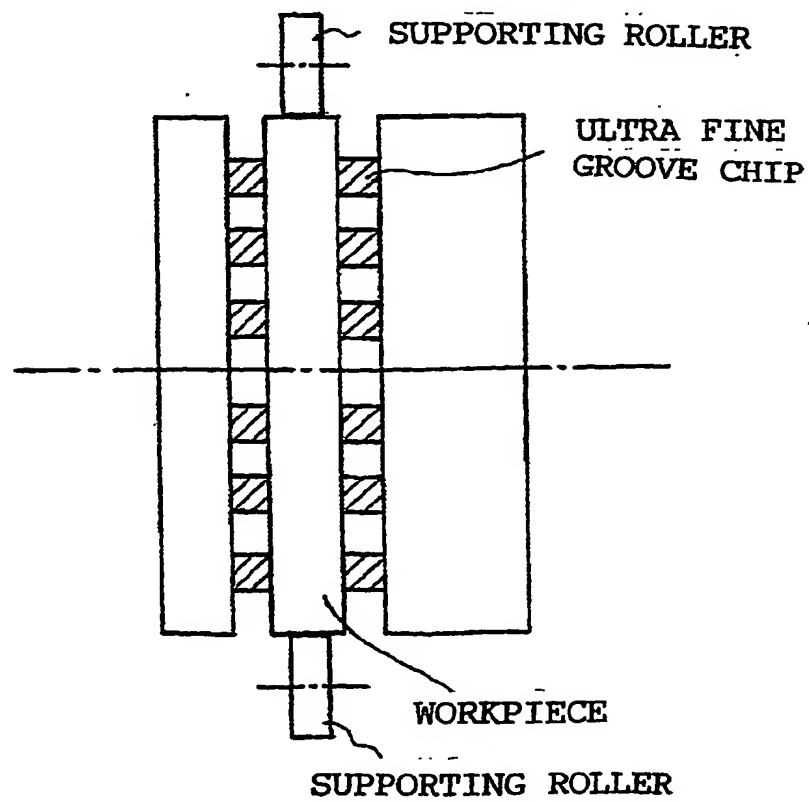
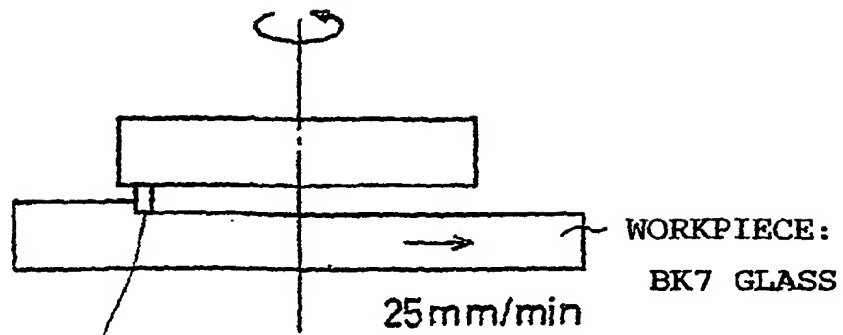


FIG. 6A



ULTRA FINE GROOVE CHIP

FIG. 6B

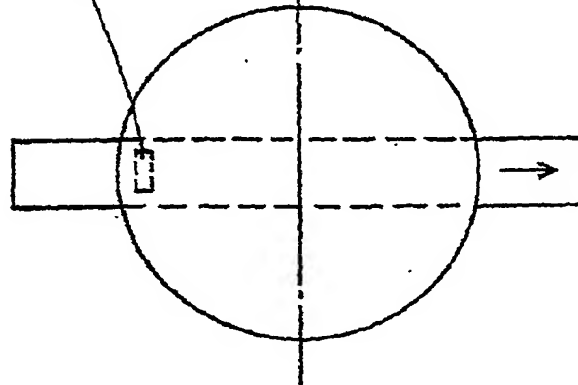


FIG. 7A

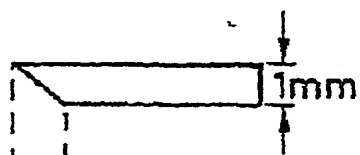
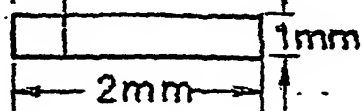


FIG. 7B



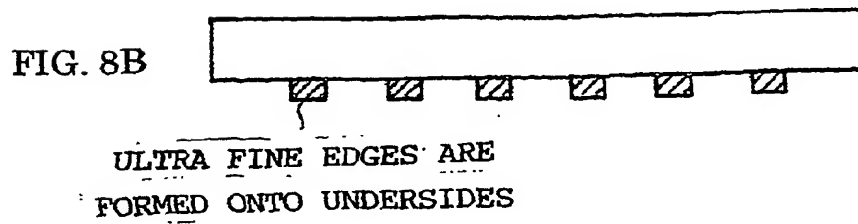
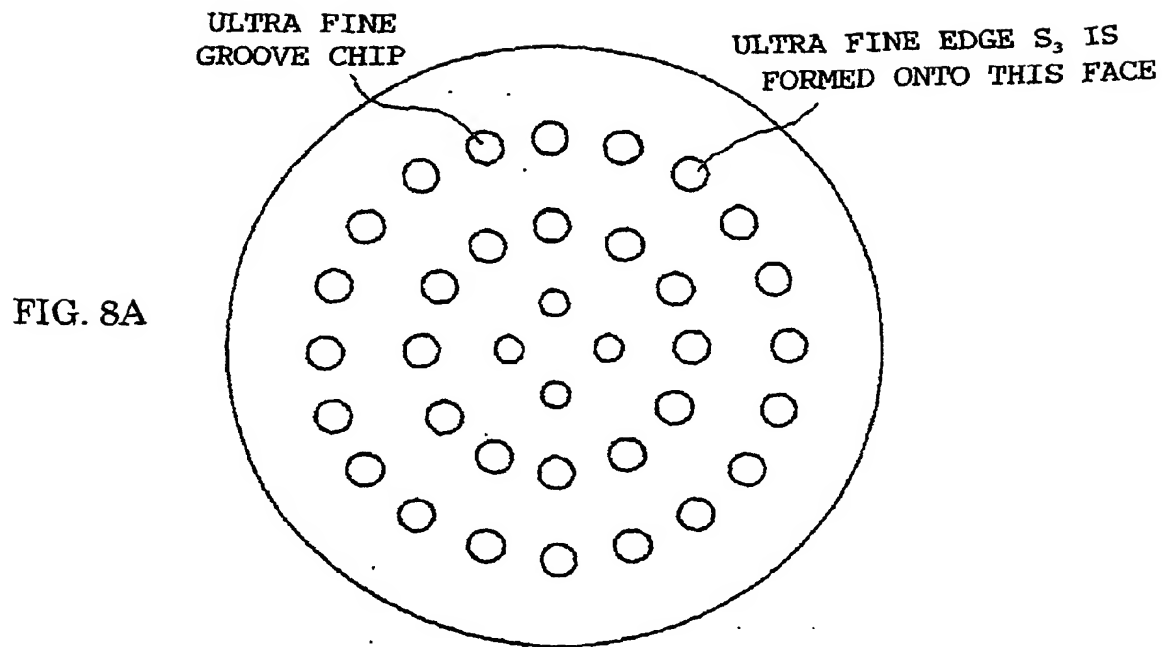


FIG. 10

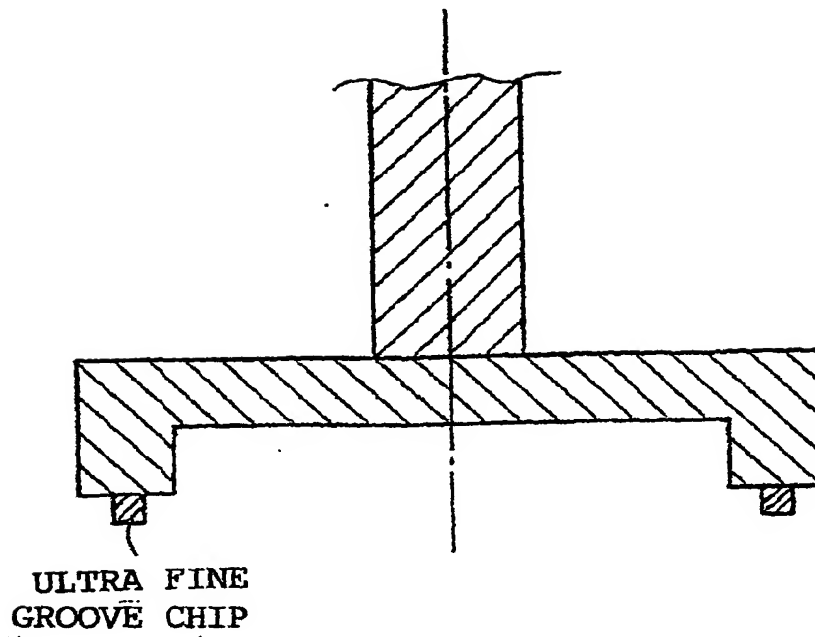


FIG. 11

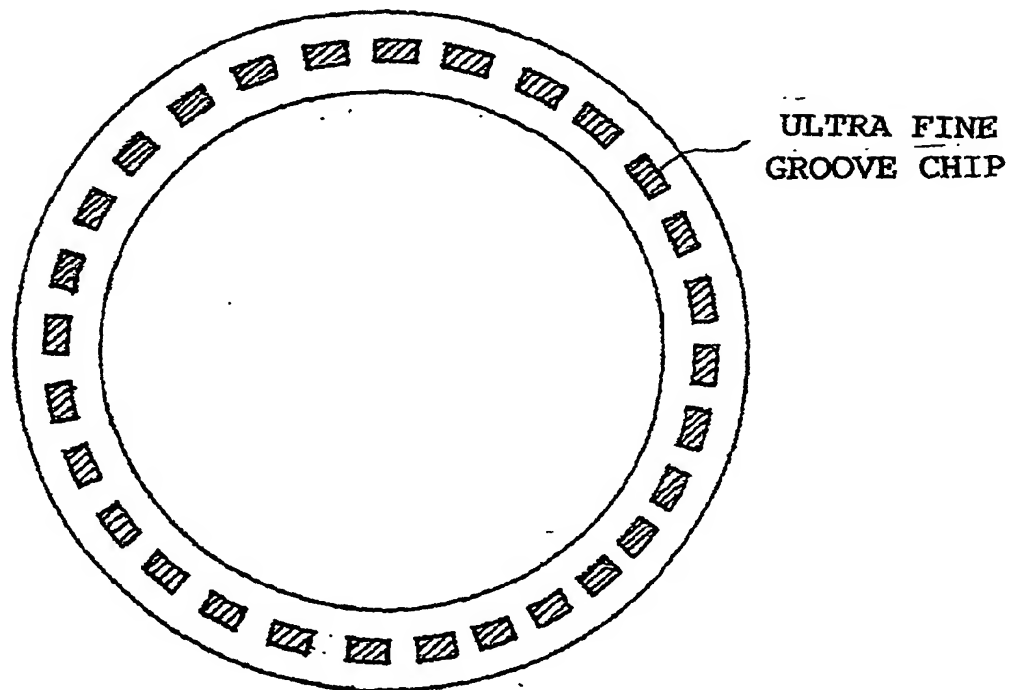


FIG. 12

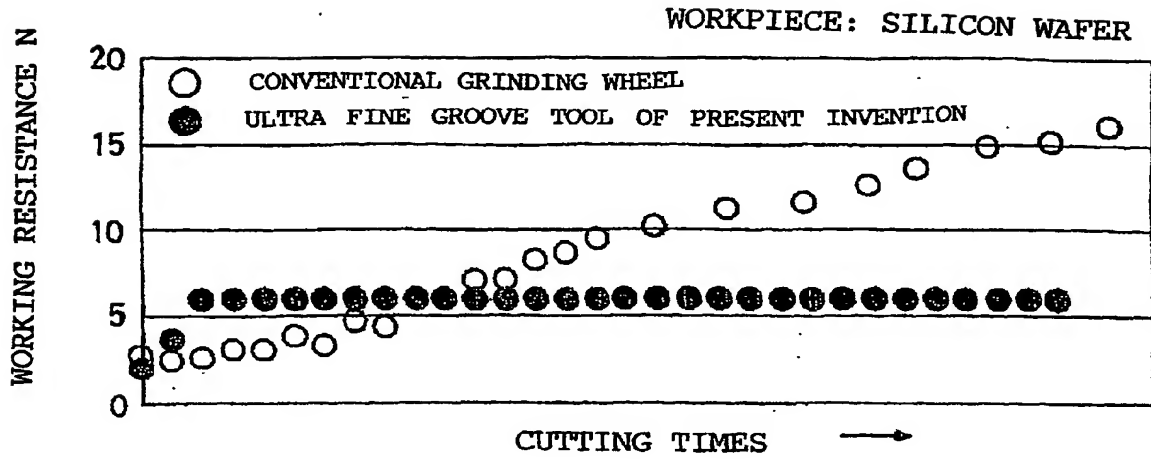


FIG. 13

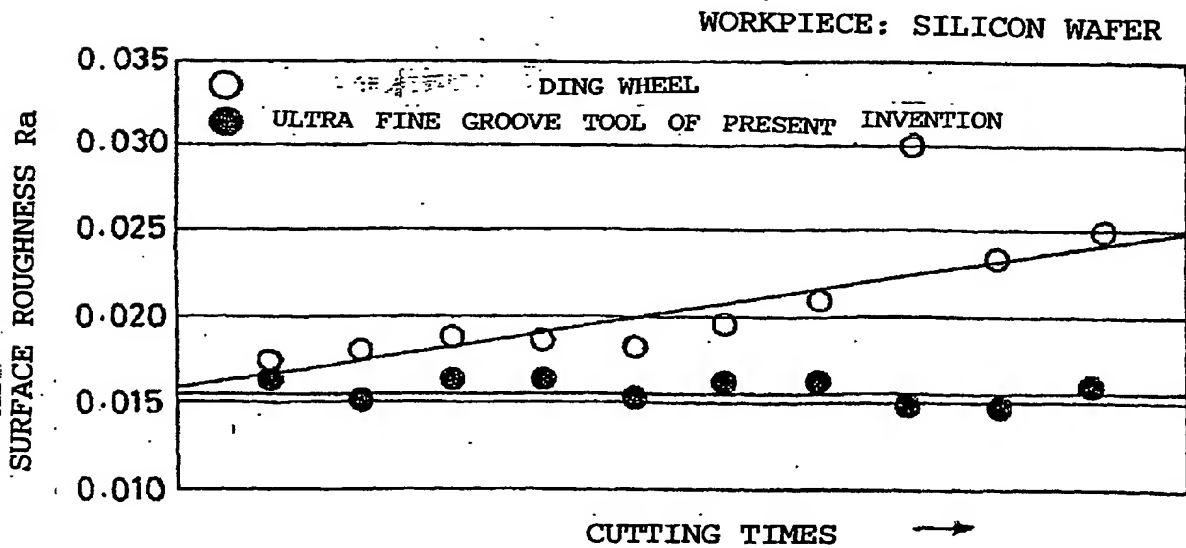


FIG. 14

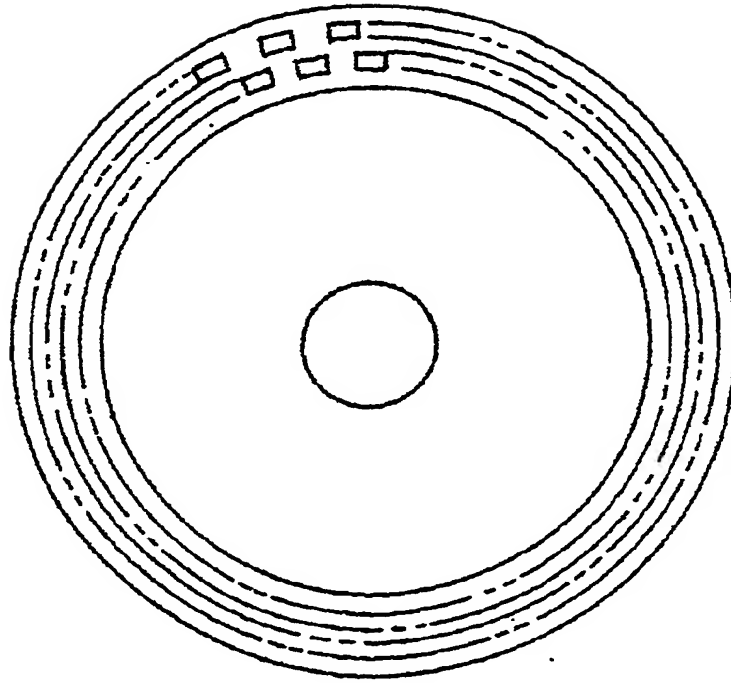


FIG. 15

